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ATTENTION: Examiner Nguyen  
GROUP ART UNIT: 2877  
FIRM/CO. NAME: United States Patent and Trademark Office  
APPLICATION NO: 10/646,943  
FAX NO: (703) 872-9306  
FROM: Ashok K. Janah  
DATE: June 16, 2004  
AMAT REFERENCE NO: 006726 USA/ETCH/CONE/JB1

TOTAL NUMBER OF PAGES 3 (INCLUDING COVER PAGE)

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BUSINESS PHONE: (415) 538-1555 FACSIMILE NO: (415) 538-8380

MESSAGE:

Examiner Nguyen,

Attached please find our response to the restriction requirement mailed on May 19, 2004, which is being timely filed within 1 month thereof.

Thank you,

Hilde Susan Jaegtne

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Barnes et al.	Group Art Unit: 2877
Serial No: 10/646,943 Confirmation No. 2974	Examiner: Sang H. Nguyen
Filed: August 21, 2003	Attorney Docket No. 006726 USA/ETCH/CONE/JB1
Title: MONITORING DIMENSIONS OF FEATURES AT DIFFERENT LOCATIONS IN THE PROCESSING OF SUBSTRATES	June 16, 2004 San Francisco, California

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RESPONSE TO RESTRICTION REQUIREMENT

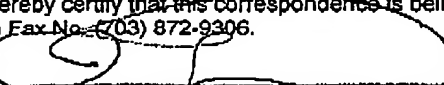
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Examiner Nguyen:

This communication is filed in response to the Restriction Requirement  
mailed on May 19, 2004, and is being timely filed within 1 month thereof.

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office  
via Fax No. (703) 872-9306.

By



Hilde Susan Jaegtnes

Date: June 16, 2004

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Application No: 10/646,943  
Page 2 of 2

### REMARKS

Applicant elects the claims corresponding to Group I without traverse, namely claims 1-19, drawn to a substrate processing apparatus and method, as defined by the Examiner.

Respectfully submitted,  
Janah & Associates, P.C.

Date: June 16, 2004

By: 

Ashok K. Janah  
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Please direct all telephone calls to: Ashok K. Janah, (415) 538-1555

Please continue to send correspondence to: Patent Department, M/S 2061  
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